

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ichiro MITSUYOSHI

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Group Art Unit: 3652

Examiner: Jennifer HERRERA

VIA EFS WEB
Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in an Office Action issued by the Japanese Patent Office on January 29, 2008 in connection with a counterpart foreign application and that this communication, to there best of applicant's knowledge, was not received by any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this Submission.

I respectfully request that the information submitted be considered and the required \$180.00 fee is also transmitted electronically herewith.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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ON MARCH 27, 2008


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